



Patent  
Docket No. H37-122 US

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant : Othmar Zuger  
Application No. : 10/530,822  
Filing Date : August 15, 2005  
For : Method and Apparatus for Processing Substrates  
Examiner : Nathan K. Ford  
Art Unit : 1792  
Confirmation No. : 2481

**6 Pages**  
**Via EFS**  
**Attn: Examiner Ford**  
**Commissioner for Patents**  
**P.O. Box 1450**  
**Alexandria, Virginia 22313-1450**

**AMENDMENT AFTER FINAL WITH RCE AND  
REQUEST FOR ONE MONTH EXTENSION OF TIME**

Sir:

Applicants hereby request, under 37 C.F.R. 1.136(a), a one (1) month extension of time within which to respond to the Final Action dated February 21, 2008; that is, up to and including June 21, 2008. The Commissioner is hereby authorized to charge Deposit Account No. 14-1431 the amount of \$930 that includes the as \$120 fee required by 37 C.F.R. 1.17(a)(1), and the fee of \$810 for the RCE due under 37 C.F.R. 1.17(e), and for any additional fees which may be due under 37 C.F.R. 1.16 or 1.17.

In response to the Final Action dated February 21, 2008, please amend the above-identified application, as follows.